

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/879,231
Filing Date June 11, 2001
Inventor Garo J. Derderian, et al.
Assignee Micron Technology, Inc.
Group Art Unit 2818
Examiner T. Lee
Attorney's Docket No. MI22-1748
Title: Capacitor Fabrication Methods and Capacitor Constructions

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

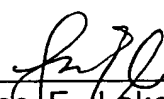
The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 09,653,149, filed August 31, 2000. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned.

37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 17 Oct 2001

By: 
James E. Lake
44,854

ONLY FOR YOUR
INFORMATION



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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

To: Assistant Commissioner for Patents
Washington, D.C. 20231

From: James E. Lake (Tel. 509-624-4276; Fax 509-838-3424)
Wells, St. John, Roberts, Gregory & Matkin P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

*12/Suppl.
I. D.S.
G. Stah
7-16-02*

This Supplemental Information Disclosure Statement is being filed in an abundance of caution to ensure consideration of the references listed on the attached form PTO-1449.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 09,653,149, filed August 31, 2000. Such prior disclosure is sufficient for the above-identified application as far as copies of references AA-AD are concerned.

37 C.F.R. § 1.98(d) and MPEP § 609(2).

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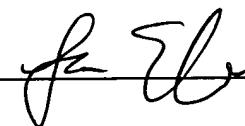
The listed references AE, AF, and the amendment to application serial no. 09/653,156 listed on page 2 are submitted to the Office with copies attached.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 11 Jun 2002

By: _____



James E. Lake
Reg. No. 44,854



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Spokane, WA 99201-3828

Dear Sir:


The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449 and copies of which are attached.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Dated: 11 Jan 2002

By: 
James E. Lake
Reg. No. 44,854

KEEP FOR YOUR
RECORDATION